



Diamond CVD Plus Graphene System

- ✚ Water cooled stainless steel high vacuum chamber
- ✚ Easy filament holder flange
- ✚ DC low voltage power supply
- ✚ Four Mass Flow Controllers of various ranges
- ✚ Standard pressure gauges
- ✚ Mechanical and Optional Turbo vacuum pump
- ✚ Optional stainless steel load lock chamber
- ✚ Linear motion motorized control of Filament to substrate distance
- ✚ Versatile 2" diameter substrate heater with optional rotation.